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Dated: Iven 25 2002 Signature

Cloen Shoffee

Recide 10/088840

Docket No.: NY-CHEMMT-206-US

8/19/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Klaus-Dieter NITTEL, et al.

Application No.: 10/088,840

Group Art Unit:

Filed: March 21, 2002

Examiner: Not Yet Assigned

For:

METHOD FOR APPLYING MANGANESE

PHOSPHATE LAYERS

PRELIMINARY AMENDMENT

Commissioner for Patents Washington, DC 20231 Box PCT

Dear Sir:

In advance of prosecution, please amend the above-identified patent application as follows:

IN THE CLAIMS

Please cancel claims 1-7, without prejudice and add the following new claims:

- 8. Method for applying manganese phosphate layers to iron or steel surfaces comprising contacting workpieces with a phosphating solution comprising
 - 0.2 to 4 g/l of iron (II) ions
 - 10 to 25 g/l of manganese ions
 - 25 to 50 g/l of phosphate ions (calc. As P_2O_5)
 - 3 to 35 g/l of nitrate ions
 - 0.5 to 5 g/l of nitroguanidine